

Electronic Patent Application Fee Transmittal

Application Number:	10550853			
Filing Date:	22-Sep-2005			
Title of Invention:	Method of epitaxial deoposition of an n-doped silicon layer			
First Named Inventor/Applicant Name:	Philippe Meunier-Beillard			
Filer:	Robert J. Crawford			
Attorney Docket Number:	NL03 0357 US1			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Filing a brief in support of an appeal	1402	1	510	510
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				510